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RULE						
APPLICANTS Christian Dussarrat, Ibaraki, JAPAN; Jean-Marc Girard, Paris, FRANCE; Takako Kimura, Tsukuba, JAPAN; Naoki Tamaoki, Tokyo, JAPAN; Yuusuke Sato, Tokyo, JAPAN;						
** CONTINUING DATA ***** This application is a 371 of PCT/IB04/01346 04/08/2004						
** FOREIGN APPLICATIONS ***** JAPAN 2003-113118 04/17/2003						
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/30/2006						
Foreign Priority claimed 35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
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TITLE Methods for producing silicon nitride films by vapor-phase growth						
FILING FEE RECEIVED 1000	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		